

BOX ISSUE FEE PATENT

IN THE U.S. PATENT AND TRADEMARK OFFICE

Application No.:

10/569,548

Conf. No.

7724

Filing Date:

February 27, 2006

Examiner:

Edna Wong

Applicant:

Kenzo MAEHASHI, et al.

Art Unit:

1759

Title:

METHOD FOR CONTROLLING STRUCTURE OF NANO-SCALE SUBSTANCE, AND METHOD FOR PREPARING LOW

DIMENSIONAL QUANTUM STRUCTURE HAVING NANO-SCALE

USING THE METHOD FOR CONTROLLING STRUCTURE

Attorney Docket:

12480-000162/US

Customer Service Window Randolph Building 401 Dulany Street Alexandria, VA 22314 **Mail Stop Issue Fee** May 11, 2011

COMMENTS ON THE EXAMINER'S STATEMENT OF REASONS FOR ALLOWANCE

Sir:

In reply to the Examiner's Statement of Reasons for Allowance provided with the Notice of Allowance dated February 17, 2011, Applicants submit the following comments.

The Examiner offers several reasons why the claims of the present application are allowable over the prior art of record, with emphasis on the irradiating step. Although Applicants agree that the various limitations mentioned in the claims are not taught or suggested by the prior art taken either individually or in combination, Applicants wish to emphasize that it is each claim, taken as a whole, including the interrelationships and interconnections between various claimed elements, which is allowable over the prior art of record.

Should there be any outstanding matters that need to be resolved in the present application, the Examiner is respectfully requested to contact the undersigned at the telephone number below.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 08-0750 for any additional fees required under 37 C.F.R. § 1.16 or under 37 C.F.R. § 1.17; particularly, extension of time fees.

Respectfully submitted,

HARNESS, DICKEY, & PIERCE, P.L.C.

By

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